

United States Patent and Trademark Office

CONFIRMATION NO. 5282

Bib Data Sheet	_							
SERIAL NUMBER 10/649,613	FILING DATE 08/28/2003 C		ASS 57	GROUP ART U 2815		UNIT	ATTORNEY DOCKET NO. NITT.0154	
APPLICANTS								
Yoshihisa Fujisaki, Hachioji, JAPAN;								
Hiroshi Ishihara, Tokyo, JAPAN;								
"* CONTINUING DATA ****** This application is a DIV of 09/984,632 10/30/2001 ABN "FOREIGN APPLICATIONS ***** JAPAN 2001-129243 04/26/2001 IF REQUIRED, FOREIGN FILING LICENSE GRANTED								
** 11/22/2003		— т				-		
35 USC 119 (a-d) conditions we was I no Met after			STATE OR	SHEETS TO		тот	AL	INDEPENDENT
met Alloviance LDE COUNTRY Acknowledged Examiner's Signature Initials JAPAN				DRAWING CLA 9 1				CLAIMS 1
ADDRESS 38327 REED SMITH LLP 3110 FAIRVIEW PARK DRIVE, SUITE 1400 FALLS CHURCH, VA 22042								
TITLE Semiconductor device and process for producing the same								
l No.					□ All Fees □ 1.16 Fees (Filing) □ 1.17 Fees (Processing Ext. of time)			